

Notice of References Cited

Application/Control No.

10/558,917

Applicant(s)/Patent Under
Reexamination
WONG ET AL.

Examiner

KEVIN M. JOHNSON

Art Unit

1793

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,439,865 A	08-1995	Abe et al.	502/333
	B	US-			
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	D	US-			
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	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Brinker et al., Evaporation-Induced Self-Assembly: Nanostructures Made Easy, 1999, Advanced Materials, 11, No. 7, p 579-585.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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